



Handwritten signature and initials in the top right corner.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9134**
Shoriki NARITA et al. : Docket No. 2001_1718A
Serial No. 09/988,704 : Group Art Unit 2625
Filed November 20, 2001 : Examiner Sheela Chawan

METHOD AND APPARATUS FOR CORRECTING
INCLINATION OF IC ON SEMICONDUCTOR WAFER

PATENT OFFICE FEE TRANSMITTAL FORM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Attached hereto is a check in the amount of \$120.00 to cover Patent Office fees relating to filing the following attached papers:

Petition for Extension of Time \$120.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.

Respectfully submitted,

Shoriki NARITA et al.

By

Handwritten signature of W. Douglas Hahm.

W. Douglas Hahm
Registration No. 44,142
Attorney for Applicants

WDH/ck
WENDEROTH, LIND & PONACK, L.L.P.
2033 K St., N.W., Suite 800
Washington, D.C. 20006-1021
Telephone (202) 721-8200
April 29, 2005

[Check No. 68010]
2001_1718A